

**Search Notes**

Application/Control No.

10/518,501

Examiner

David Y. Chung

Applicant(s)/Patent under  
Reexamination

REY-MERMET ET AL.

Art Unit

2871

**SEARCHED**

Class	Subclass	Date	Examiner
349	149	10/2/2006	DC
349	150	10/2/2006	DC
349	151	10/2/2006	DC
349	152	10/2/2006	DC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
same	same	10/2/2006	DC

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	10/2/2006	DC